



PATENT APPLICATION  
Docket No. 5484-048  
Client No. PX828-US/SSD

# 29  
Amoldt  
I  
8/14/03  
ORJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM, et al      Confirmation No.      1838  
Serial No.      09/305,240      Examiner:      Nadav, Ori  
Filed:      May 4, 1999      Group Art Unit:      2811  
For:      OPEN DRAIN INPUT/OUTPUT STRUCTURE AND  
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR  
DEVICE

MAIL STOP NON FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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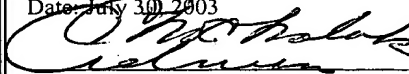
AMENDMENT

Responsive to the Office Action dated May 13, 2003, please amend the application as follows.

**Amendments to the Claims** are found in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: July 30, 2003

  
Adrienne Chocholak